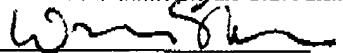


Docket No.: P2002,1010

CERTIFICATION OF MAILING OR TRANSMISSION
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 or facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below.


Werner H. Stemmer

Date

October 20, 2005

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OCT 20 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/723,631 Confirmation No: 9710
Applicant : Frank-Michael Kamm
Filed : November 26, 2003
Title : REFLECTION MASK FOR PROJECTING A STRUCTURE ONTO
A SEMICONDUCTOR WAFER AND METHOD FOR PRODUCING
THE MASK
Art Unit : 1756
Examiner : Stephen D. Rosasco

Docket No. : P2002,1010
Customer No. : 24131

R E S P O N S E

Hon. Commissioner for Patents

Sir:

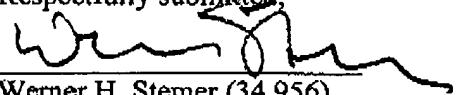
Responsive to the Office Action dated September 26, 2005, the following remarks are made:

In deference to the restriction requirement on pages 2 and 3 of the above-identified Office Action, applicant elects group I, claims 1-5 for prosecution at this time.

Applicant requests a rejoinder of the non-elected claims upon the conclusion of the prosecution of claims 1-5.

In view of the foregoing, the early issuance of an Action on the merits of claims 1-5 is solicited.

Respectfully submitted,


Werner H. Stemmer (34,956)

Date: October 20, 2005

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